
Session Title: 63. OLED Manufacturing and Equipment

Date: Aug. 26, 2016 (Friday)

Time: 10:30~11:40

Room: Room G (Room 401)

Session Chair: Prof. Seungjun Yi (Korea Univ., Korea)

G63-1

10:30~10:55

[Invited] Ultra-High Gas Barrier Coating Technology for Flexible AMOLEDs

MunPyo Hong, YunSung Jang, and Seungjun Yi (Korea Univ., Korea)

G63-2

10:55~11:10

Plane Source Evaporation for New Patterning Techniques of High Resolution AMOLEDs

Chanhun Hwang, Young Im, JJ Kim, HS Park, JS Choi, and YM Oh (Sunic System Co., Ltd., Korea)

G63-3

11:10~11:25

Improvement in 8th Generation Linear Source for AMOLED TV Mass Production

Sungmoon Kim, Daejoon Ji, Hyun Seo, Eunsang Jung, Younghyuck Na, and Jungkyu Lee (R&D Center of YAS Co., Ltd., Korea)

G63-4

11:25~11:40

Full Roll-to-Roll OLED Fabrication Using Silver Nanowire-Coated PET Films

Eun Jung, Bongsung Kim, Haksoo Lee, Chanho Kim, Minha Kim, Yeongeun Sul, Jintaek Han, Hokyoon Chung, and Sungmin Cho (Sungkyunkwan Univ., Korea)